



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: )  
John M. de Larios ) Group Art Unit: 1746  
Application No. 10/608,871 ) Examiner: Unassigned  
Filed: June 27, 2003 ) Atty. Docket No. LAM2P422  
For: METHOD AND APPARATUS FOR REMOVING ) Date: March 8, 2004  
A TARGET LAYER FROM A SUBSTRATE USING )  
REACTIVE GASES )

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on March 8, 2004.

Signed: \_\_\_\_\_

  
Sylvia Castillo

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider these references and to acknowledge such consideration by initialing the appropriate location on the attached PTO Form 1449.

This Information Disclosure Statement (IDS) is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This IDS is believed to be filed before the mailing date of a first Office Action. Accordingly, it is believed that no fees are due in connection with the filing of this IDS. However, if it is determined that any fees are due, then the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. LAM2P422).

Respectfully submitted,  
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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Attorney Docket No:</b> U.S. LAM2P422 10/608,871 <b>Applicant:</b> John M. de Larios <b>Filing Date:</b> June 27, 2003 <b>Group:</b> 1746
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**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class
	A	2002/0094684	7/18/02	Hirasaki et al.	438	689
	B					
	C					
	D					
	E					
	F					
	G					
	H					
	I					
	J					
	K					

**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	L							
	M							
	N							
	O							
	P							

**Other Documents**

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	R	
	S	
	T	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.